

**In the Specification:**

Page 1, between lines 1 and 2, insert: --This application is a divisional of Serial No.

09/693,765; filed on October 20, 2000.--

**In the Title:**

Please change the title to the following title:

Method For Changing An Electrical Resistance Of A Resistor

**In the Abstract:**

Please amend as follows:

A method ~~and structure~~ for changing an electrical resistance of a resistor. Initially, the resistor is provided, wherein the resistor has a length  $L$  and an electrical resistance  $R_1$ . A portion of the resistor is exposed to a laser radiation, wherein the portion includes a fraction  $F$  of the length  $L$  of the resistor. ~~Both  $F = 1$  and  $F < 1$  are within the scope of the present invention.~~ After the resistor has been exposed to the laser radiation, the resistor has an electrical resistance  $R_2$ , wherein  $R_2$  is unequal to  $R_1$ . ~~The change in resistance from  $R_1$  to  $R_2$  is due to a heating of the resistor by the laser radiation, which causes a chemical or structural change within the resistor.~~ ~~Either  $R_2 > R_1$  or  $R_2 < R_1$  depending on the material composition of the resistor.~~